

10/583942

Docket No. 8007-1111

AP3 Rec'd PCT/PTO 22 JUN 2006
PATENT

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Atsushi SAKURAI et al.

Conf.

Application No. **NEW NATIONAL PHASE**

Group

Filed June 22, 2006

Examiner

METAL COMPOUND, MATERIAL FOR THIN FILM FORMATION, AND PROCESS OF FORMING THIN FILM

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

June 22, 2006

Sir:

The following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begin on page 2 of this paper.

Remarks begin on page 6 of this paper.